# Organic One-Transistor-Type Nonvolatile Memory Gated with Thin Ionic Liquid-Polymer Film for Low Voltage Operation

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## **S** Supporting Information

[AB](#page-6-0)STRACT: [As one of th](#page-6-0)e most emerging next-generation nonvolatile memories, one-transistor (1T)-type nonvolatile memories are of great attention due to their excellent memory performance and simple device architecture suitable for high density memory arrays. In particular, organic 1T-type memories containing both organic semiconductors and insulators are further beneficial because of their mechanical flexibility with low cost fabrication. Here, we demonstrate a new flexible organic 1T-type memory operating at low voltage. The low voltage operation of a memory less than 10 V was obtained by employing a polymer gate insulator solution



blended with ionic liquid as a charge storage layer. Ionic liquid homogeneously dissolved in a thin poly(vinylidene fluoride-cotrifluoroethylene) (PVDF-TrFE) film gave rise to low voltage operation of a device due to its high capacitance. Simultaneously, stable charge trapping of either anions or cations efficiently occurred in the polymer matrix, dependent upon gate bias. Optimization of ionic liquid in PVDF-TrFE thus led to an air-stable and mechanically flexible organic 1T-type nonvolatile memory operating at programming voltage of  $\pm 7$  V with large ON/OFF current margin of approximately  $10^3$ , reliable timedependent data retention of more than  $10^4$  seconds, and write/read endurance cycles of 80.

KEYWORDS: organic memory, field effect transistor memory, ionic liquid-polymer gate insulators, low voltage operation, charge trapping memory, flexible memory

## 1. INTRODUCTION

One-transistor (1T)-type nonvolatile memories, based on nondestructive bistable electrical conductance of semiconductor channel gated by functional insulators, are of great interest due to their excellent memory performance and very simple device architecture suitable for high density memory arrays. The 1T-type nonvolatile memories can be categorized in terms of the origin of bistable semiconducting channel conductance into charge trapping memories<sup>1</sup> and ferroelectric ones,<sup>2</sup> with at least two different levels of gate-programmed charge storage and spontaneous polarizatio[n](#page-6-0), respectively. Vario[us](#page-6-0) novel materials have been developed for high performance 1T-type memory including ferroelectrics,<sup>2,3</sup> charge trapping<sup>4−7</sup> and blocking layers,<sup>8−11</sup> electrodes,<sup>12</sup> and semiconductors.<sup>13−19</sup> As a result, the memory performanc[e w](#page-6-0)as significantly i[m](#page-6-0)[pr](#page-7-0)oved such as end[uranc](#page-7-0)e,  $^{20,21}$  da[ta](#page-7-0) retention,  $^{3,10,21,22}$  [prog](#page-7-0)ram speed,<sup>22,23</sup> flexibility,<sup>24–26</sup> printing capability,<sup>27</sup> ON/OFF memory [ma](#page-7-0)rgin,  $20,28$  [and](#page-7-0) operating voltag[e,](#page-6-0)  $8,29$  making these types [of m](#page-7-0)emories co[mpeti](#page-7-0)tive with conventional [fl](#page-7-0)oating gate ones. Moreover, [the o](#page-7-0)rganic 1T-type memori[es c](#page-7-0)ontaining both organic semiconductors and insulators offer additional benefits of low cost, easy fabrication, and mechanical flexibility in particular when these layers are solution-processed.

Among technological issues that still limit the utilization of the memory, high voltage operation of an organic 1T memory

is one of the most serious obstacles which should be overcome with a top priority. In fact, most organic 1T memory devices need a gate voltage, often ranging from  $\pm 13$  to over 200 V due to the use of thick ferroelectric or charge trapping and blocking layers to reduce the leakage current resulting from numerous structural defects, including pinholes, residual solvent, and grain boundaries.<sup>1,2</sup> Several 1T-type nonvolatile memories operated below  $\pm 10$  V have recently been demonstrated. The key materials f[or t](#page-6-0)he low voltage operation were, however, based on either vacuum deposited organic or inorganic oxide semiconductors<sup>17,30</sup> with organic/inorganic hybrid insulating layers such as  $AIO_{x0}^{\quad 6-8,14}$   $TiO_{x}^{\quad 10}$  and organosilicate,<sup>31</sup> making it difficult fo[r](#page-7-0) [the](#page-7-0)se approaches to be cost-effective and more importantly [mechan](#page-7-0)ically [fl](#page-7-0)exible. We envision[ed](#page-7-0) that high capacitance ionic liquids, which have been widely employed to organic field effect transistors (OTFTs) for low voltage operation,32−<sup>34</sup> can be also suitable for 1T type nonvolatile memory as long as gate-field dependent bistable conductance is guarantee[d](#page-7-0) [wit](#page-7-0)h reliable time-dependent data retention and read−write cycle endurance.

Received: August 25, 2014 Accepted: October 24, 2014 Published: October 24, 2014

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Figure 1. (a) Schematics illustrating the operation of an organic 1T-type nonvolatile memory with a P3HT channel and an EMI[TFSA]-PVDF-TrFE insulator film. Photograph (right) and SEM image (left) of the plan and cross-sectional views of a 1T-type memory device, respectively, are also shown with the chemical structure of P3HT, EMI[TFSA], and PVDF-TrFE. (b)  $I_{DS}-V_G$  transfer curves of a device containing an IL-polymer film with 10 wt % EMI[TFSA] concentration. The current hysteresis arises from the nonvolatile charge storage of the IL-polymer film. (c) The timedependent retention characteristics of  $I_{\text{DS}}$  values established in the 1T-type memory device. The ON and OFF states were programmed or erased at  $V_G$  of  $\pm$ 7 V.

Here, we present a highly reliable and flexible organic 1Ttype memory with low voltage operation. A memory operating at voltage of less than 10 V was obtained by employing a polymer gate insulator solution-blended with ionic liquid (IL) as a charge storage layer. IL homogeneously dissolved in a thin poly(vinylidene fluoride-co-trifluoroethylene) (PVDF-TrFE) film allowed for the low voltage operation of a device due to its high capacitance. Simultaneously, stable charge trapping of either anions or cations efficiently occurred in the polymer matrix, dependent upon gate bias. Optimization of IL in PVDF-TrFE thus led to an air-stable and mechanically flexible organic 1T-type nonvolatile memory operating at programming voltage of  $\pm$ 7 V with large ON/OFF current margin of approximately  $10<sup>3</sup>$ , reliable time-dependent data retention of more than  $10<sup>4</sup>$ seconds and write−read endurance cycles of 80.

### 2. EXPERIMENTAL SECTION

Materials and Film Preparation. PVDF-TrFE with 25 wt % TrFE (MSI Sensors), poly(3-hexylthiophene) (P3HT) (Sigma-Aldrich, Korea), and poly(vinylidene fluoride-co-hexafluoropropylene) (PVDF-HFP) (Sigma-Aldrich, Korea) were used without further purification. P3HT has weight-average molecular weight  $(M_w)$  of 180 000 g mol<sup>−</sup><sup>1</sup> with 98.5% head to tail regioregularity.<sup>24</sup> Samsung Electronics Co. Ltd. kindly provided poly(vinylidene-fluoride− trifluoroethylene−chlorotrifluoroethylene) (PVDF-TrFE-[CT](#page-7-0)FE) with its monomer ratio of 66:34:8.3. 1-Ethyl-3-methylimidazolium bis- (trifluoromethylsulfonyl) amide (EMI[TFSA]) (Tokyo Chemical Industry Co) and organic solvents including methyl ethyl ketone (MEK), acetone, and chloroform (Sigma-Aldrich, Korea) were used as received. A P3HT solution in chloroform (1 wt %) was spin-coated at 2000 rpm for 60 s on prepatterned Au S/D electrodes thermally deposited on either a  $Si/SiO<sub>2</sub>$  (200 nm) or a polyimide substrate. The IL-polymer solutions were prepared by codissolving polymers and EMI[TFSA] in MEK and spin-coated at 1500 rpm for 60 s on a P3HT layer. For IL-PVDF-TrFE films, the concentration of PVDF-TrFE was

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Figure 2. (a) Thickness of IL-polymer films as a function of EMI[TFSA] concentrations with respect to PVDF-TrFE. (b) ON and OFF current values of 1T-type memories with various IL-polymer insulators. The read voltage  $(V_G)$  was 0 V. The sets of more than 5 cells were used to obtain the distribution of both ON/OFF current values. (c)  $I_{DS}$  values of 1T-type memory devices with IL-polymer insulators obtained at a read voltage after various program  $V_G$  in the dc sweep mode. (d) Specific capacitance from capacitance−voltage measurements at  $V = 0$  of Au/IL-polymer film/highly doped Si capacitors as a function of IL concentrations.

maintained at 10 wt % in solvent, while the IL concentration was varied from 3, 5, 7, 10, 15, 20, and 30 wt % with respect to PVDF-TrFE.

Capacitor Fabrication and Characterization. Highly doped Si/ IL-polymer films/metal capacitors were fabricated as described in our previous works.<sup>24</sup> Patterned Au top electrodes were thermally evaporated on IL-polymer films using a shadow mask (SNTEK MEP5000). C−V [ch](#page-7-0)aracteristic was measured at a frequency of 100 Hz under ambient conditions (Agilent 4284A precision LCR meter). The thickness of IL-polymer films was evaluated using an Alpha step 500 surface profiler (AS500) (KLA-Tencor Co.).

Fabrication and Characterization of 1T-Type Memory. Topgate-bottom-contact polymer memories were fabricated similarly to our previous devices with ferroelectric polymers.<sup>24,29</sup> On the patterned 30 nm thick Au S/D electrodes thermally evaporated on a substrate, an approximately 50 nm thick P3HT layer and a th[in](#page-7-0) fi[lm](#page-7-0) formation of an IL-polymer insulator were sequentially spin-coated. The PVDF-TrFE/ ionic liquid solution in MEK rarely affected the P3HT layer. After removal of the residual solvent by thermal treatment at 60 °C for 2 h, arrays of 70 nm thick top gate Al electrodes were thermally deposited. Oxygen plasma produced by reactive ion etching (RIE) (Femto VITA-4E) was treated to make the Au S/D electrodes accessible with contact probe tips, giving rise to top-gate bottom-contact polymer memories, as illustrated in the schematic in Figure 1a. The electrical properties of devices were examined by characterization systems (E5270B, Agilent Technologies, 2636A, Keithley Instruments Inc.) in ambient conditions. The dynamic characteris[tic](#page-1-0)s were measured using a Keithley 4200-SCS semiconductor parameter analyzer.

Structure Characterization. The molecular and microstructures of the films were examined using optical microscope (OM) (Olympus BX 51M), field emission scanning electron microscopy (FESEM, LEO

1550 VP), tapping mode atomic force microscopy (TM-AFM, Nanoscope IV a Digital Instruments), and two-dimensional (2D) grazing-incidence wide-angle X-ray scattering (GIWAXS) as described in detail in our previous works.<sup>2</sup>

#### 3. RESULTS AND DISC[USSIO](#page-7-0)N

Arrays of organic 1T-type memory devices with top-gate bottom-contact structure consisting of polymeric semiconductor and charge trap-detrap layer were constructed on a  $Si/SiO<sub>2</sub>$ wafer or a flexible substrate as shown in Figure 1a. Crosssection of an organic 1T-type memory device was also visualized in Figure 1a. Our organic 1T-type mem[ory](#page-1-0) showed p-type output characteristics in the source-drain current  $(I_{DS})$ versus source-drain [vo](#page-1-0)ltage  $(V_{DS})$  curve as expected (Supporting Information, Figure S1). Hysteresis loop as a function of a gate voltage  $(V_G)$  was observed in the transfer char[acteristics](#page-6-0) (at a  $V_{DS}$  of −1 V), as shown in Figure 1b. The  $I_{DS}$  hysteresis [curves](#page-6-0) [were](#page-6-0) [pro](#page-6-0)gressively developed with gate voltage sweep and fully saturated at the voltage swee[p](#page-1-0) less than  $\pm 10$  V as shown in Figure 1b. Furthermore, the bistable ON and OFF current values were retained for more than  $10^4$  seconds, as shown in Figure [1c](#page-1-0). Our results are promising when compared with recent state-of-the art research in which the organic 1Ttype polymer m[em](#page-1-0)ory with vacuum deposited semiconductor operated at  $\pm 13$  V.<sup>35</sup> Furthermore, the memory performance of our organic 1T device is very comparable with that of a device containing inorga[nic](#page-7-0) dielectric layer and/or semiconductor, as shown Supporting Information, Table 1.

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Figure 3. (a) Switching behaviors from OFF to ON state of a ferroelectric 1T memory with a pure PVDF-TrFE insulator and an organic 1T memory containing an IL-polymer film with 10 wt % EMI[TFSA] concentration with respect to PVDF-TrFE as a function of the width of pulsed voltage train. Voltage pulses of −7 and −35 V were programmed to the gate for the organic and ferroelectric 1T memory devices, respectively. While the ferroelectric memory was turned on even with  $10^{-2}$  second pulse, the organic 1T memory was switched after 1 s pulse. (b)  $I_{DS}$  dynamics with  $V_G$ sequence program (P)-read (R)-erase (E)-read (R) ( $\pm$ 5 V, 1 s pulse width) at  $V_{DS} = -1$  V. (c) The ON and OFF current values of an organic 1T device with IL-polymer film having 10 wt % EMI[TFSA] concentration as a function of temperature. (d) Normalized ON current data retention with respect to time of an organic 1T-type memory examined at various temperatures.

We hypothesized that the hysteresis was attributed to the gate voltage dependent bistable storage of ions at the interface between IL-polymer insulator and P3HT. After a large negative  $V_G$  of more than  $-4$  V is applied, the anions, which have been homogeneously dissolved throughout polymer matrix, start to move into the interface, resulting in a rapid increase of the  $I_{DS}$ owing to hole accumulation in the P3HT channel as shown in Figure 1a. When the  $V_G$  returned to zero, the  $I_{DS}$  still remained high because of anions physically trapped at the interface. Positiv[e](#page-1-0)  $V_G$  subsequently applied to the device gradually detraps anions and at the same time began to trap cations at the interface, leading to a rapid decrease of  $I_{DS}$ . Again, when the  $V_G$ became zero, the  $I_{DS}$  remained low due to the trapped cations at the interface.

We investigated the memory performance of the devices as a function of the amounts of IL. The IL-polymer films with different EMI[TFSA] compositions showed the similar thickness of approximately  $2 \mu m$ , as shown in Figure 2a. Apparently, ON current increased with increasing IL due to the increase of interfacial charge density as shown in Figure [2b](#page-2-0) (Supporting Information, Figure S2a). The gate leakage current of an ILpolymer film increased with IL concentratio[ns](#page-2-0) d[ue to facile](#page-6-0) [formation of](#page-6-0) continuous ion channels through the film with IL (Supporting Information, Figure S2b). The gate leakage level of our device with a 10 wt % IL-polymer film is comparable with that of the previous ion-gel gated transistor.<sup>36</sup> As shown in the results of current variation as a function of sweep program voltage in Figure 2c, current hysteresis is f[ully](#page-7-0) saturated below 10 V of a device containing EMI[TFSA] more than 7 wt % with respect to PVDF-[T](#page-2-0)rFE. On the other hand, a device with a neat PVDF-TrFE insulator showed a saturated  $I_{DS}$  hysteresis with a gate voltage sweep above  $\pm 100$  V due to the large coercive field of a PVDF-TrFE for ferroelectric polarization switching (50 MV/m) (Supporting Information, Figure S2d).

The capacitance−voltage (C−V) and capacitance−frequency characteri[stics were examined from](#page-6-0) Au/IL-polymer films/highly doped Si capacitors with different IL compositions. When the forward and backward bias was swept from −2 to +2 V, the capacitors showed typical C−V curves (Supporting Information, Figure S3a), $37$  and the specific capacitances of the ILpolymer films were obtained at 0 V. Ionic-liquid fi[lms largely](#page-6-0) [decr](#page-6-0)ease at high fr[eq](#page-7-0)uency due to slow motion of ions as shown in Supporting Information, Figure S3b. The measured maximum capacitances at 100 Hz are approximately  $\sim$ 1 µF cm<sup>−</sup><sup>2</sup> [, while a pure PVDF-Tr](#page-6-0)FE shows a specific capacitance value of ∼30 nF cm<sup>−</sup><sup>2</sup> , as shown in Figure 2d. The large capacitance values of the IL-polymer films are attributed to the electrical double layers at the interface between [th](#page-2-0)e electrodes

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Figure 4. (a) TM-AFM images in height mode and (b) GIWAXS patterns of the IL-polymer films on P3HT layer as a function of EMI[TFSA] concentration with respect to polymer. (c) fwhm values of equatorial azimuthal intensity profiles of  $q_z = (110)$  and/or (200) peaks as a function of EMI[TFSA] concentratons. (d) A schematic illustration of microstructure of the IL-polymer film in which ions were preferentially dissolved in the amorphous regions of semicrystalline PVDF-TrFE matrix.

and ionic liquids. In fact, the capacitances of our thin solid ILpolymer films can further increase with IL and become comparable with those of ion gels reported previously.<sup>36,38</sup> The amount should be, however, optimized for reliable memory performance. For instance, in spite of the square[-like](#page-7-0) current hysteresis with a large ON/OFF ratio in a device containing 30 wt % IL, ON current data retention with time was poor with significant drop of an initial current level within 500 s (Supporting Information, Figure S2c). Anions could be easily detrapped at the interface due to their strong interaction with n[earby cations abundant i](#page-6-0)n such a high concentration of IL. It should be also noted that the equivalent PVDF-TrFE thickness of our IL-polymer film with 10 wt % EMI[TFSA] concentration calculated at 100 Hz is approximately 50 nm which is thin enough for device operation below 10 V. Our ILpolymer film with bistable charge storage capability as well as high capacitance gave rise to novel organic 1T-type memory with low voltage operation.

To further reveal the operation mechanism of our memory, we investigated its switching behavior in comparison with a conventional ferroelectric 1T memory with a pure PVDF-TrFE insulator whose switching time was approximately  $10^{-3}$  to  $10^{-4}$ seconds.<sup>22</sup> Furthermore, the dynamic switching response of a device was measured as a function of pulse widths. Switching betwee[n](#page-7-0) program and erase states occurred upon the application of gate voltage pulses with the drain voltage at −1 V. The memory margin of current ON/OFF ratio of approximately  $10^2$  was maintained during the dynamic switching with 1 s pulse width. As shown in Figure 3a,b and Supporting Information, Figure S4a−c, our devices require switching times longer than 1 s due to rather sl[ow](#page-3-0) ionic motion.<sup>39</sup> [One possible](#page-6-0) way to reduce switching time of our device would be to employ a high  $k$  polymer matrix whose strong [po](#page-7-0)larization can make anion−cation pairs readily dissociated, leading to the enhancement of ion mobility.<sup>40</sup> For instance, a poly(vinylidenefluoride−trifluoroethylene− chlorofloroethylene) can be a good candidate for the purpo[se](#page-7-0) with its dielectric constant of approximately  $60.^{41}$  We also examined current hysteresis and time-dependent retention behavior of a device as a function of temperature [as](#page-7-0) shown in Figure 3c,d, respectively (also see Supporting Information, Figure S4d). The device showed the good bistable current

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Figure 5. (a) Schematic of the fabrication of a micropatterned IL-polymer film by microimprinting. SEM image of a topographically patterned EMI[TFSA]/PVDF-TrFE (10/90) film after thermal imprinting with a prepatterned PDMS mold consisting of 30 μm hexagons in size. The inset shows a photograph of a micron-thick free-standing solid IL-polymer film. The write/erase endurance cycles (b) and time-dependent retention characteristics (c) of bistable  $I_{DS}$  values of an organic 1T-type memory fabricated on a polyimide substrate. The  $I_{DS}$  values of a flexible organic 1Ttype memory as a function of (d) the bending radius and (e) the number of bending cycles at a bending radius of 5.8 mm. The inset in part d is a photograph of a flexible organic IL-polymer memory in situ measured under bending.

behavior at temperatures up to 150 °C which is well above the Curie temperature of PVDF-TrFE ( $T_c = 120$  °C). In general, the pure PVDF-TrFE behaves as a dielectric with high polarization above the Curie temperature. As the temperature increased to 120 °C, the ON current data retention gradually degraded because of lower activation energy for ionic transport in PVDF-TrFE matrix, and ill-defined hysteresis curve was obtained at 200 °C due to melting of PVDF-TrFE (Figure 3d). It should be, however, noted that our memory has thermal operation margin up to at least 70 °C. Not surprisingly, [o](#page-3-0)ur organic 1T-type IL-polymer memory devices were also successfully fabricated with other nonferroelectric polymers

such as PVDF-HFP and PVDF-TrFE-CTFE, making our method universal (Supporting Information, Figure S5). The results in Figure 3 support the ion trapping and detrapping principle of our device.

The molecular [an](#page-3-0)[d](#page-6-0) [microstructures](#page-6-0) [of](#page-6-0) [the](#page-6-0) IL-polymer films on P3HT surface were visualized by TM-AFM and 2D GIWAXS. All IL-polymer films with various IL concentrations exhibited the characteristic PVDF-TrFE crystalline structures with randomly distributed needle-like microdomains, and representative surface morphologies are shown in Figure 4a (also see Supporting Information, Figure S6a). The microdomains of PVDF-TrFE increased in size with EMI[TFS[A\]](#page-4-0)

<span id="page-6-0"></span>concentration due to the solvating effect of IL on polymer crystallization (Supporting Information, Figure S6a). The rootmean-square (RMS) roughness of IL-polymer films was also measured using AFM, as plotted Supporting Information, Figure S6b. The RMS of active layer, P3HT, is approximately 0.691 nm. The roughness of dielectric layer did not change significantly with IL concentrations but abruptly increased at high IL concentration over 20 wt %. It should be noted that a 10 wt % IL-polymer film we used for memory device has its roughness similar to that of a neat PVDF-TrFE film. The 2D GIWAXS patterns of IL-polymer films on P3HT are shown in Figure 4b and Supporting Information, Figure S7. These patterns display a reflection at a scattering vector,  $q_z$ , of approxi[m](#page-4-0)ately  $1.40-1.41$  Å<sup>-1</sup> preferentially intensified at the meridian, arising from (110) or (200) plane of the PVDF-TrFE crystals.42,43 The diffraction patterns also show multiple reflections at  $q_z$  of approximately 0.37 Å<sup>-1</sup> corresponding to the  $(100)$  plane of P3HT crystals.<sup>44</sup> The results apparently indicate that both PVDF-TrFE and P3HT have their chains aligned parallel to the surface. Mo[reo](#page-7-0)ver, as the amount of EMI[TFSA] increased, the full width half-maximum (fwhm) of the azimuthal angle intensity of  $q_z$ , (110) or (200) peaks, increased as shown in Figure 4c, which implies that the preferred orientation of the PVDF-TrFE crystals was slightly destroyed with IL. The molecula[r](#page-4-0) and microstructures of ILpolymer insulators in conjuction with both switching and temperature dependent memory performance clearly suggest that anions and cations were properly trapped and detrapped, dependent upon gate bias, in the amorphous regions of PVDF-TrFE near the interface with P3HT as shown in the scheme of Figure 4d. It should be noted that various structural properties (e.g., chemical structure, vacancy, aggregate, solvent residue, and et[c.](#page-4-0)) of polymer films can also play a role in charge trapping−detrapping behaviors, thus memory effects in transistors. Furthermore, the role of the interface between semiconducting and dielectric layer is of prime importance in our memory device. We believe that ions are preferentially trapped and detrapped at the interfacial regions. In addition, on the basis of the previous work in which PVDF crystals were not damaged with ionic liquid,<sup>36</sup> we assume that the ions were preferentially located in the amorphous regions of PVDF-TrFE at the interface with P3HT[.](#page-7-0)

Our thin solid IL-polymer films with good thermal stability are conveniently combined with direct thermoimprinting for fabricating micropatterns, and the results are shown in Figure 5a. An IL-polymer film was compressed at 160 °C and the low pressure of 5 kPa with a prepatterned poly(dimethylsiloxane) [el](#page-5-0)astomeric (PDMS) mold as shown in the scheme of Figure 5a. A topographic microstructure with periodic hexagonal holes was readily developed over the large area. Furthermore, a [m](#page-5-0)echanically flexible organic 1T-type memory was successfully fabricated on a conventional polyimide substrate. The device programmed at  $\pm$ 7 V again shows reliable nonvolatile memory performance comparable with that on  $Si/SiO<sub>2</sub>$ , as shown in Figure 5b,c. However, as shown in Figure 5b, the OFF current tends to increase with write−erase cycle numbers possibly due to the [in](#page-5-0)crease of the deeply trapped anio[ns](#page-5-0) IL into the P3HT with cycles. A charge blocking layer can be considered to resolve the issue. The ON and OFF current values at a read voltage of −1 V were rarely fluctuated under various in situ bending conditions with the lowest bending radius of 5.8 mm, as shown in Figure 5d (Supporting Information, Figure S8a). Figure 5e shows that ON and OFF current margin of the device

was not significantly altered even after more than 1000 bending cycles at a radius of 5.8 mm (Supporting Information, Figure S8b). Beneficially, our organic 1T type memory was also extremely air-stable, and thus, its performance was maintained even after air-exposure of a device for 2 months without significant degradation (Supporting Information, Figure S9).

#### 4. CONCLUSIONS

In summary, we demonstrated organic 1T-type nonvolatile memory operating at low voltage of  $\pm$ 7 V with excellent data reliability. The performance was attributed to our novel charge storage layers of IL-polymer films prepared by solutionblending of insulating polymers and ionic liquids. The EMI[TFSA] in the film significantly reduced the operating voltage due to its high capacitance. More importantly, ions accumulated and physically trapped in the amorphous regions of PVDF-TrFE near the interface with semiconductor gave rise to good data reliability. Thin solid IL-polymer films with both mechanical and thermal stability allowed for a flexible memory that exhibited ON/OFF current ratio of  $10^3$ , data retention of approximately  $10<sup>4</sup>$  seconds and read and write cycle endurance of 80. Furthermore, the device was tolerant upon more than 1000 bending cycles at a bending radius of 5.8 mm. Our results clearly indicate that the developed flexible, air-stable nonvolatile polymer memory even without elaborately designed charge control layers can be readily combined with other emerging mobile organic electronic devices.

#### ■ ASSOCIATED CONTENT

## **6** Supporting Information

AFM images, GIWAX data, MFM, and I−V characteristics results. This material is available free of charge via the Internet at http://pubs.acs.org/.

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#### Notes

[The authors declare](mailto:cmpark@yonsei.ac.kr) no competing financial interest.

#### ■ ACKNOWLEDGMENTS

This research was supported by Samsung Research Funding Center of Samsung Electronics under Project SRFC-MA1301- 03.

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